

SPECIFICATION

DIELECTRIC BARRIER DISCHARGE LAMP DRIVE CIRCUIT

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TECHNICAL FIELD

The present invention relates to a discharge lamp, and more specifically, to a drive circuit for lighting a so-called dielectric barrier discharge lamp provided with a
10 current limiting function for preventing impedance of the discharge lamp itself from causing overcurrent when emitting light through discharge.

BACKGROUND ART

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Known dielectric barrier discharge lamps have a planar or cylindrical shape. As shown in Fig. 8, a flat panel discharge lamp (refer to, for example, patent publication 1) has dielectric plates 11 and 12, which resemble glass plates
20 and which are arranged facing each other. The space between the edges of the opposing surfaces of the dielectric plates 11 and 12 are sealed by a sealing member (e.g., seal glass) 13 so as to form a dielectric sealed container. Discharge gas 16 is contained in the dielectric sealed container, and
25 electrodes 14 and 15 are attached facing each other with the dielectric plates 11 and 12 and the discharge gas 16 located in between thereby forming a discharge space. Fluorescent layers 17 and 18 are formed on the opposing inner surfaces of the dielectric plates 11 and 12 when necessary. As the
30 discharge gas 16, Xe (xenon) gas is used. Alternatively, mercury vapor and Ar (argon) or Ne (neon) gas etc. is used.

In a light emission drive circuit for the flat panel

discharge lamp 19, AC power from, for example, a commercial power supply 21 is rectified and smoothed by a rectification smoothing circuit 22 so as to form a DC power supply 23. The DC power from the DC power supply 23 is converted to
5 high frequency power by an inverter 24. The high frequency power is boosted by a transformer 25 and applied between the electrodes 14 and 15 so that discharge occurs between the dielectric plates 11 and 12 (referred to as dielectric barrier discharge since the discharge occurs with the
10 dielectric plates 11 and 12). This generates discharge plasma formed by ionization of the discharge gas 16 and externally irradiates ultraviolet rays. Alternatively, the fluorescent layers 17 and 18 are excited by the ultraviolet rays and natural light is externally irradiated. That is,
15 light emission occurs to light the discharge lamp 19. The dielectric plate 12 on the side opposite the illumination surface may be a metal plate and may be used to also function as the electrode 15. The electrode 14 on the illumination surface side may be a transparent electrode
20 when necessary, and the fluorescent layer 17 may be omitted.

Since AC power is applied to the discharge lamp 19 through the two dielectric plates 11 and 12, that is, through a thick barrier even after being lighted, the high
25 frequency voltage applied between the electrodes 14 and 15 must be extremely high. In addition, since the impedance between the electrodes 14 and 15 is mainly based on the electrostatic capacity of the dielectric plates 11 and 12, the phase of the current that flows during the application
30 of voltage advances greatly and lowers the power factor. Therefore, the power capacity (VA) of a circuit such as the step-up transformer 25 and the inverter 24 becomes extremely large compared to the actual capacity (W) applied to the

discharge lamp 19, that is, the power loss becomes large. Thus, equipment used as the flat panel discharge lamp lighting device becomes extremely large and it becomes difficult to make the equipment thinner or lighter.

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To solve this problem, the thickness of the barrier may be reduced, that is, the thickness of the dielectric plates 11 and 12 may be reduced. Since the mechanical strength would become insufficient, ribs may be arranged at
10 appropriate intervals between the dielectric plates 11 and 12. However, when used in the field of illumination in which a relatively large area is required, the arrangement of a plurality of ribs as reinforcement members will affect the uniformity of light emission in an undesirable manner.
15 Further, the manufacturing steps would increase thereby raising costs.

An example of a dielectric barrier discharge lamp having a cylindrical shape is shown in Fig. 9. Dielectric
20 tubes 51 and 52, which may be coaxial glass tubes, respectively have one end closed by plates 51a and 52a and another end sealed by a sealing member (e.g., seal glass) 53. The dielectric tubes are fixed to each other to form a dielectric sealed container. Discharge gas 54, such as
25 xenon gas, mercury vapor and neon, or argon gas, is contained in the dielectric sealed container. Electrodes 55 and 56 are formed facing each other entirely on the outer surface of the dielectric tube 51 and the inner surface of the dielectric tube 52 with the dielectric tubes 51, 52 and
30 the discharge gas 54 located in between so as to define a discharge space. A fluorescent layer 57 is formed entirely on the inner surface of one of the dielectric tubes 61 when necessary.

An example in which the tube has a cylindrical shape is shown in Fig. 10. The dielectric sealed container is formed by a dielectric tube 61 such as a glass tube having two
5 closed ends, with discharge gas 62 contained in the sealed container. Electrodes 63 and 64 are formed facing each other on the outer surface of the dielectric tube 61 spaced by distance D1 with the dielectric tube 61 and the discharge gas 62 located in between to form a discharge space. The
10 fluorescent layer 65 is formed on the inner surface of the dielectric tube 61 when necessary.

An inductance element is connected in series to a normal fluorescent lamp to prevent overcurrent after the
15 fluorescent lamp is lighted. However, in the above dielectric barrier discharge lamps in which the electrodes are formed facing each other with a dielectric body and discharge gas located in between to form the dielectric sealed container, the dielectric body of the sealed
20 container acts as a relatively high impedance with respect to the high frequency current after lighting. Since the discharge lamp itself has a current limiting function to prevent overcurrent from flowing after lighting, this is advantageous in that a current limiting inductance element
25 does not need to be added, as apparent from the description of, for example, patent publication 2.

[Patent Publication 1] Japanese Laid-Open Patent Publication No. 2003-31182 (Fig. 2)

30 [Patent Publication 2] Japanese Laid-Open Patent Publication No. 11-307051 (paragraph number [0019])

DISCLOSURE OF THE INVENTION

It is an object of the present invention to provide a dielectric barrier discharge lamp drive circuit driven by relatively low voltage and having a small power loss with a simple configuration, that is, without using reinforcement members in the dielectric sealed container even when the dielectric barrier discharge lamp has a relatively large area and includes a dielectric container having a thickness for sufficient strength.

One aspect of the present invention is a dielectric barrier discharge lamp drive circuit including a sealed container having a dielectric body and containing discharge gas, and a pair of electrodes, facing each other on the sealed container with the dielectric body and the discharge gas located therebetween. The drive circuit includes a drive AC generation circuit for generating high frequency power applied between the pair of electrodes, and a reactor member connected in series between the drive AC generation circuit and the discharge lamp.

In the present invention, the impedance of the dielectric barrier discharge lamp when viewed from the drive circuit corresponds to a reduced impedance of a dielectric electrostatic capacitor forming discharge space with the impedance of a reactor component member. The reduced impedance enables the drive voltage to be decreased. Thus, a dielectric body having a thickness for solely obtaining sufficient mechanical strength may be used. Further, the power factor is improved and loss is reduced. Additionally, there is no need for the structure of the discharge lamp to be complicated, and the size and weight may be reduced with a light emission surface having a relatively large area.

The dielectric body forming the discharge space may be planar and formed by two flat plates or may be cylindrical and formed by two curved plates.

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BRIEF DESCRIPTION OF THE DRAWINGS

Fig. 1 is a diagram showing a basic configuration example of a drive circuit according to the present invention;

10 Fig. 2A is a diagram showing an equivalent circuit of the drive circuit of Fig. 1 before lighting;

Fig. 2B is a diagram showing an equivalent circuit of a stable lighting state of the drive circuit of Fig. 1;

15 Fig. 2C is a diagram showing a simplified equivalent circuit of the drive circuit of Fig. 1;

Fig. 3 is a diagram showing an example of an impedance frequency characteristic when viewing the discharge lamp from the drive circuit;

20 Fig. 4 is a circuit diagram showing a drive circuit according to a first embodiment of the present invention;

Fig. 5 is a circuit diagram showing a drive circuit according to a second embodiment of the present invention;

Fig. 6A is diagram showing an equivalent circuit of the drive circuit of Fig. 5;

25 Fig. 6B is a diagram showing a circuit example for measuring equivalent leakage reluctance of the drive circuit of Fig. 5;

Fig. 7A is a diagram showing an example of a leakage transformer 37 of the drive circuit of Fig. 5;

30 Fig. 7B is a diagram showing another example of the leakage transformer 37 of the drive circuit of Fig. 5;

Fig. 8 is a diagram showing a conventional flat panel discharge lamp drive circuit;

Fig. 9A is a cross-sectional diagram of a conventional cylindrical discharge lamp taken along line 9A-9A in Fig. 9B;

Fig. 9B is a cross-sectional diagram taken along line 9B-9B in Fig. 9A showing the cylindrical discharge lamp;

Fig. 10A is a cross-sectional taken along line 10A-10A of Fig. 10B showing another conventional cylindrical discharge lamp; and

Fig. 10B is a cross-sectional diagram taken along line 10B-10B in Fig. 10A showing the cylindrical discharge lamp.

BEST MODE FOR CARRYING OUT THE INVENTION

[Basic Configuration]

The basic configuration of a dielectric barrier discharge lamp drive circuit according to the present invention will now be described with reference to Fig. 1 using a flat panel discharge lamp as an example. In the present invention, high frequency power of, for example, about 10 kHz to 100 kHz from a drive AC generation circuit 31 is applied to a flat panel discharge lamp 19 via a reactor member 32. Parts of a discharge lamp 19 corresponding to those shown in Fig. 8 are denoted with the same reference number. The advantages of the reactor member 32 and the preferred inductance value will now be described.

An equivalent circuit including the flat panel discharge lamp 19 is shown in Fig. 2. Fig. 2A shows a state before the discharge lamp 19 is lighted. In this state, high frequency power of voltage E from drive AC generation circuit 31 is applied to a series-connected circuit including inductance L_e (correctly, the inductance value representing the inductance element of L_e , same expressions

are used hereinafter) of the reactor member 32,
electrostatic capacitors C1 and C2 corresponding to each
plate thickness of dielectric plates 11 and 12, and an
electrostatic capacitor C3 of the discharge space between
5 the dielectric plates 11 and 12.

When the discharge lamp 19 is lighted, as shown in Fig.
2B, resistors R1 and R2 are respectively inserted to be
connected in series to the capacitors C1 and C2 of the
10 dielectric plates 11 and 12, a resistor R3 is connected in
parallel to the capacitor C3 of the discharge space, a
resistor R4 is connected in series to the inductance Le of
the reactor member 32, and an internal resistor r of the
drive AC generation circuit 31 is connected in series to the
15 inductance Le. The resistor R3 of the discharge space is a
resistor for the discharge current and is significantly
small. Therefore, the capacitor C3 of the discharge space
is in a substantially short circuited state by the resistor
R3.

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The equivalent circuit of Fig. 2B may be simplified by
grouping the same components as shown in Fig. 2C. That is,
the AC power E is applied to the series-connected circuit of
the inductance Le, the capacitor Ce and the resistor Re.
25 The capacitor Ce is a series-connected capacitor mainly
including the capacitors C1 and C2, and the resistor Re is a
series-connected resistor including the resistors R1, R2,
R3, and r.

30 As can be understood from the equivalent circuit shown
in Fig. 2C, the dielectric impedance of the reactor member
32 cancels at least part of the capacitive impedance of the
dielectric plates 11 and 12. This lowers the application

voltage in the lighted state and improves the power factor. The inductance L_e of the reactor member 32 is selected so as to be greater than the impedance of when the equivalent circuit shown in Fig. 2C is resonated but less than the impedance of when the reactor member 32 is not employed. That is, the synthetic impedance Z_0 of the discharge lamp 19 when viewed from the drive AC generation circuit 31 is expressed by the following equation.

$$Z_0 = R_e + j[\omega L_e - 1/(\omega C_e)] \quad (1)$$

The frequency characteristic of the synthetic impedance Z_0 is shown by the solid line in Fig. 3. The frequency characteristic of the impedance Z_i of when the reactor member 32 is not employed is shown by the broken line in Fig. 3. As apparent from Fig. 3, Z_0 is slightly smaller than Z_i when the frequency $f(\omega/2\pi)$ of the high frequency power is low, decreases in a relatively sudden manner as the frequency approaches the resonance frequency $F_0(2\pi F_0 = \omega_0, \omega_0 = \sqrt{1/(L_e C_e)})$, and increases in a relatively sudden manner when becoming higher than F_0 . In comparison, Z_i gradually becomes smaller as the frequency becomes higher. At the resonance frequency F_0 , the impedance Z_0 becomes significantly small as shown by R_e and causes the flow of overcurrent. Therefore, at the frequency f_u of the high frequency power generated by the drive AC generation circuit 13, the inductance L_e is selected so that Z_0 is less than Z_i and so that Z_0 is not in a resonance state. It is considered that a current limiting impedance element does not have to be inserted since the dielectric barrier discharge lamp itself has a current limiting function. However, since the impedance Z_i of the discharge lamp itself is too large in the dielectric barrier discharge lamp, the impedance Z_i of

the dielectric barrier discharge lamp itself is lowered using the reactor member 32 in the present invention so that the synthetic impedance Z_0 with the impedance Z_i of the dielectric barrier discharge lamp itself is set to the intended current limiting value. This technique basically differs from a technique for inserting an impedance element having a current limiting function to increase the impedance of the fluorescent lamp itself during a discharging state in the conventional fluorescent lamp.

In the discharge barrier discharge lamp, discharge does not simultaneously start between each part (point) of the opposing electrodes, which have a large area, but starts at one certain part somewhere and then spreads out so that the entire surface enters a discharging state. From this aspect as well, the impedance Z_0 of a certain extent is required in the discharging state. The required impedance becomes greater as the area of the electrodes 14 and 15 becomes larger and becomes greater as the pressure of the discharge gas of the discharge lamp 19 becomes higher. Therefore, the inductance L_e is selected so that the synthetic impedance Z_0 is set to the current limiting impedance necessary for uniform light emission of the discharge lamp 19.

Further, it is desirable that the discharge gas does not contain mercury in terms of environmental aspects. In this regard, Xe (xenon) gas is currently considered to be effective as the non-mercury discharge gas. The Xe gas has lower light emitting efficiency as the frequency increases. Therefore, as shown in Fig. 3, the inductance L_e is preferably selected so that the used high frequency power frequency f_u is lower than the resonance frequency F_0 of the synthetic impedance Z_0 and so that the impedance Z_{01} obtained

by decreasing the impedance $2\pi f_u L_e$ of the inductance L_e at the frequency f_u from the impedance Z_i at the frequency f_u is set to the current limiting impedance Z_{01} necessary in the discharging state. If the light emitting efficiency is not
5 much affected, the inductance L_e may be selected so that the current limiting impedance Z_{01} is set at a state in which the frequency f_u is higher than the resonance frequency F_0 . That is, L_e may be selected so that the used frequency f_u is positioned at the steep gradient parts 26 and 27 in the
10 resonance frequency curve.

[First Embodiment]

A dielectric barrier discharge lamp drive circuit
15 according to a first embodiment of the present invention will now be described with reference to Fig. 4. The DC power from a DC power supply 23 is converted to high frequency power by an inverter 33 in a drive AC generation circuit 31. The high frequency power is boosted from about
20 12 V to about 1 kV to 2 kV by a step-up transformer 25. The boosted high frequency power is then applied to the flat panel discharge lamp 19 via an inductance element 32a, which functions as the reactor member 32. The DC power supply 23 may be configured, for example, so that the DC power is
25 generated by rectifying commercial AC power, as shown in Fig. 8.

The inverter 33 may have a configuration similar to that of the prior art. As shown in Fig. 4, a series-
30 connected circuit of switching elements Q1 and Q2 and a series-connected circuit of switching elements Q3 and Q4 are connected to the DC power supply 23. A primary coil of the transformer 25 is connected to a connecting point of the

switching elements Q1 and Q2 and the connecting point of the
switching elements Q3 and Q4. A drive circuit 34 is
connected to a DC power supply 23. The drive circuit 34
distributes an oscillation signal of an oscillator 35
5 arranged therein, drives the switching elements Q1 to Q4,
simultaneously activates the switching elements Q1 and Q4,
inactivates the switching elements Q2 and Q3, and
alternately performs activation of the switching elements Q2
and Q3 and inactivation of the switching elements Q1 and Q4.
10 By driving the switching elements in the above manner, the
high frequency AC power generated by the primary coil of the
transformer 25 is boosted by the transformer 25.

The inductance value L_e of the inductance element 32a
15 functioning as the reactor member 32 is selected so that the
value set as the intended current limiting impedance Z_{01} is
obtained by measuring the impedance Z_i in the lighted state
of the flat panel discharge lamp 19 when the inductance
element 32a is not connected and subtracting the impedance
20 $j\omega L_e$ from the impedance Z_i . That is, L_e satisfying the
following equation is used.

$$L_e = (Z_i - Z_{01}) / (2\pi f_u) \quad (2)$$

25 Alternatively, since the electrostatic capacities C_1
and C_2 of the used dielectric plates 11 and 12 and the
equivalent resistance R_e in Fig. 2C are obtained through
calculation, equation (2) may all be obtained through
calculation. The selection of L_e does not need to be that
30 accurately determined as apparent from the above
description, and L_e may be selected so that the used
frequency f_u is around or relatively close to the resonance
frequency F_0 .

Instead of arranging the inductance element 32a on the secondary side of the transformer 25, the inductance element 32b may be connected in series to the primary coil of the transformer 25 as shown by the broken lines in Fig. 4. This would enable the withstanding voltage of the inductance element 32b and the withstanding voltage of the inductance element 32b and the housing of the drive AC generation circuit 31 to be set lower than when the inductance element is arranged on the secondary side of the transformer 25. Further, insulation is facilitated.

The advantages of the present invention as described above are obtained by using the inductance elements 32a and 32b. Further, since an operation state close to series-connected resonance is obtained by inserting the inductance element 32a or 32b even if the output signal of the inverter 33 is a square wave, the voltage waveform to be applied to the flat panel discharge lamp 19 becomes closer to a sine wave. This is advantageous in that a high frequency noise is not externally generated.

A proper state may not necessary be realized even if the inductance value L_e is set as described above. Thus, it is preferable that, for example, a variable resistor 36 be connected to the oscillator 35 as part of an oscillation frequency determining element of the oscillator 35 in the inverter 33, as shown in Fig. 4, to adjust the oscillation frequency of the oscillator 35, that is, the used frequency f_u , and to set the current limiting current in the lighted state to the intended value. Deviations in the resonance point F_0 due to the type of flat panel discharge lamp 19 of manufacturing variations of the lamp is easily absorbed by

finely adjusting the frequency f_u of high frequency power.

[Second Embodiment]

5 A dielectric barrier discharge lamp drive circuit according to a second embodiment of the present invention will now be described with reference to Fig. 5. In the second embodiment, the high frequency AC power from the AC power generation circuit 31 is applied to the flat panel
10 discharge lamp 19 via a leakage transformer 37, which functions as the reactor member 32. In the example shown in Fig. 5, the leakage transformer 37 is connected to the output of the inverter 33 in place of the transformer 25 of Fig. 4, and a flat panel discharge lamp 19 is directly
15 connected to the leakage transformer 37. For example, a neon transformer used to light the neon lamp is used to prevent overcurrent in a lighted state. However, the leakage transformer is not used as the transformer 25 as shown in Fig. 8 since the dielectric barrier discharge lamp itself
20 has the current limiting function, as described above. The second embodiment is configured so that the reactance component of the leakage transformer 37 cancels the electrostatic capacitor component in the lighted state of the flat panel discharge lamp 19, that is, so that the
25 resonating state is approached by the two components.

It is apparent that the equivalent circuit for the second embodiment has the configuration shown in Fig. 6A from the known equivalent circuit of a normal transformer or
30 leakage transformer. That is, a parallel-connected circuit of the inductance L_1 and the resistor R_4 is connected to the drive AC generation circuit 31, and the flat panel discharge lamp 19 is connected via the series-connected circuit of the

inductance L2 and the resistor R5. More accurately, the equivalent inductance L2 functions as the reactance of the reactor member 32.

5 Accordingly, in the second embodiment, the inductance L2 is selected so as to have a value similar to the inductance value of the inductance element 32a or 32b mentioned above. The secondary side of the leakage transformer 37 is short circuited as shown in Fig. 6B, and
10 the short circuit current I is measured by an ammeter 38. The short circuit current I has a relationship in which the applied high frequency voltage E, L2 and the applied high frequency voltage frequency f_u satisfies $I = E / (j2\pi f_u L2)$. The voltage E is gradually increased from a small value, and the
15 voltage E is set so that the current I becomes a rated current in a lighted state of the flat panel discharge lamp 19. Here, L2 is obtained from E, I, and f_u . Since L2 is proportional to the leakage amount of the magnetic flux, the leakage amount may be adjusted to set L2, that is, the
20 reluctance L_e to the above value.

 An example of the leakage transformer 37 is shown in Fig. 7. In Fig. 7A, end faces of leg portions 41a, 41b, 41c and 42a, 42b, 42c in two E-shaped magnetic cores 41 and 42
25 are abutted against each other, and primary coil 37p and secondary coil 37s are each wound around each of the middle leg portions 41b and 42b. Leakage magnetic portions 43a and 43b of a magnetic material projecting towards the middle leg portions 41b, 42b are each coupled to the two leg portions
30 41a and 41c located at the outer sides between the primary coil 37p and the secondary coil 37s. The amount of leakage magnetic flux, that is, the leakage inductance L2 is determined by the distance or the opposing area of the

magnetic gap 44a and 44b between the leakage magnetic portion 43a and 43b and the leg portion 41b and 42b. As shown in Fig. 7B, the leakage magnetic portions 43a and 43b may be omitted, and the magnetic gap 44 may be formed
5 between the leg portions 41b and 42b in the E-shaped magnetic cores 41 and 42 without the leg portions 41b and 42b contacting each other. The leakage transformer 37 may have any configuration and be a pot shaped magnetic core or an inner core type, and in particular, may be a transformer
10 that produces leakage magnetic flux without forming a magnetic gap since the frequency f_u of the high frequency power is high.

In the second embodiment, the leakage transformer 37
15 functions as the step-up transformer 25 and the reactor member 32. Thus, the number of components is small and costs are low. In the second embodiment, a configuration in which the frequency of the high frequency power is adjustable is also used so that the current limiting
20 impedance Z_0 is set to an appropriate value.

In the above description, the inverter 33 is not limited to a bridge type and may have other configurations such as a center tap type, an amplifier type, or the like.
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The present invention is not only applicable to the flat panel discharge lamp but is also applicable to the cylindrical discharge lamp shown in Fig. 9 and Fig. 10.